

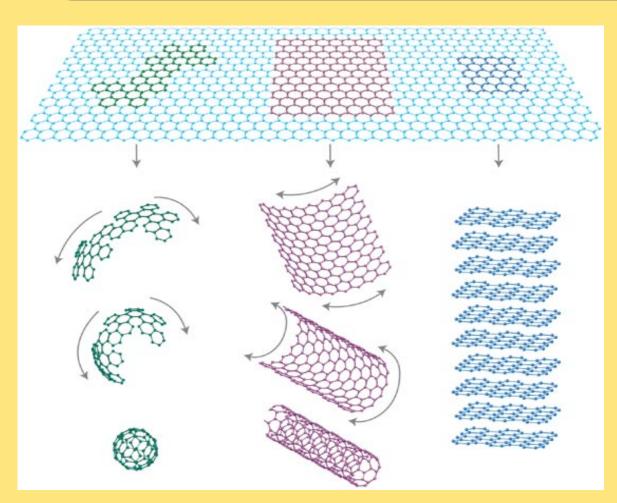
# **FLUORINE-ETCHED NANOSTRUCTURES FOR ENERGY STORAGE** APPLICATIONS



## Abstract

Graphene has been the focus of much current research, due to its interesting electrical and structural properties for electronics applications. Here we show that fluorine can be introduced during graphene growth on stainless steel (SS) substrates to simultaneously create useful nanostructures, using the chemical vapor deposition (CVD) technique. These structures are geometrically optimal for reversible ion intercalation, where the graphene acts as an electrode and the SS is a current collector. Direct growth of graphene on electrode materials makes this process very scalable and cost-effective method for developing thin-film energy storage devices.

### Introduction



Since the two-dimensional carbon structure, known as graphene, was discovered in 2004, it has been a very promising material for various applications such as solar cells, sensors, transistors, inert coatings, etc..

Figure 1: Changing the configuration of the honeycomb lattice illustrates graphene's ability to form buckyballs, carbon nanotubes, and Graphite

Graphene can be a useful battery electrode due to its superior electrical conductivity, high surface area and a broad electrochemical window.

Originally, exfoliated graphene coated on to conducting electrodes resulted in poor adhesion and electrical contact. Chemical vapor deposition (CVD) allows graphene to be grown directly on substrates.

### **Experimental Methods**

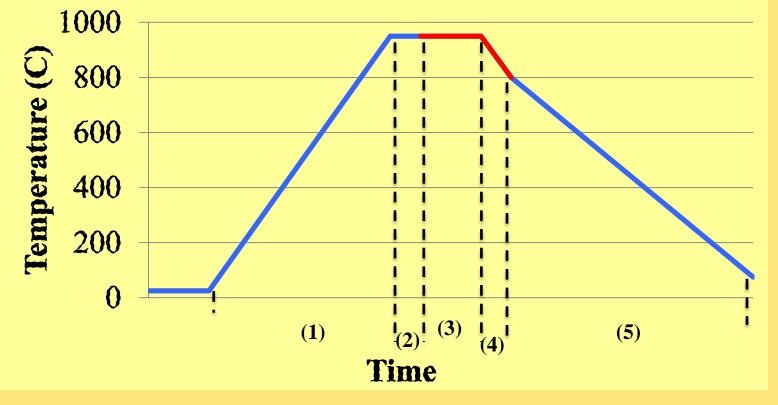


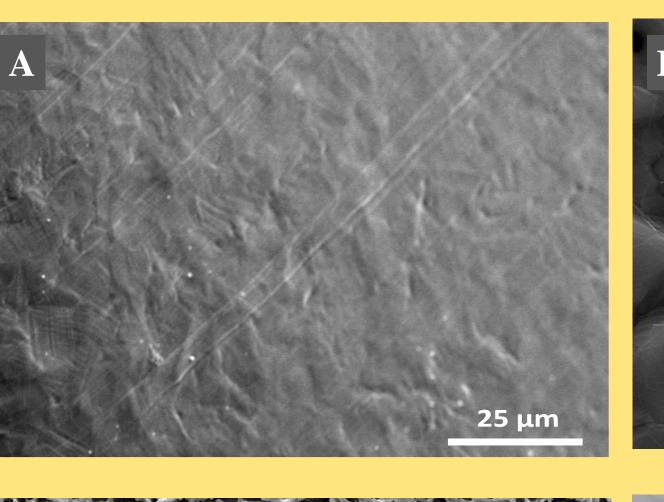
Figure 2: Schematic of optimized growth process, (1) Ar/H<sub>2</sub> 30 minute heating cycle. (2) Annealing time and 2 minute Ar flush. (3) 10 minute exposure to organic compound and fluorine etch. (4) 2 Cs<sup>-1</sup> cooling rate while exposed to organic compound. (5) C diffusion under gradual cooling.

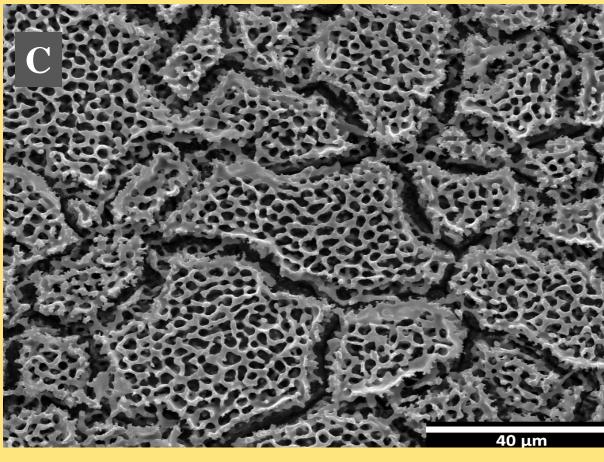
- 1. Create SS discs with constant diameter for coin-cells
- 2. Etch nanostructures on to the substrate using fluorine-based organic vapors
- 3. Allow carbon diffusion of carbon as SS cools to produce graphene
- 4. Analyze under scanning electron microscope (SEM) and Raman Spectroscope
- 5. Load sample in device and obtain charge/discharge profile

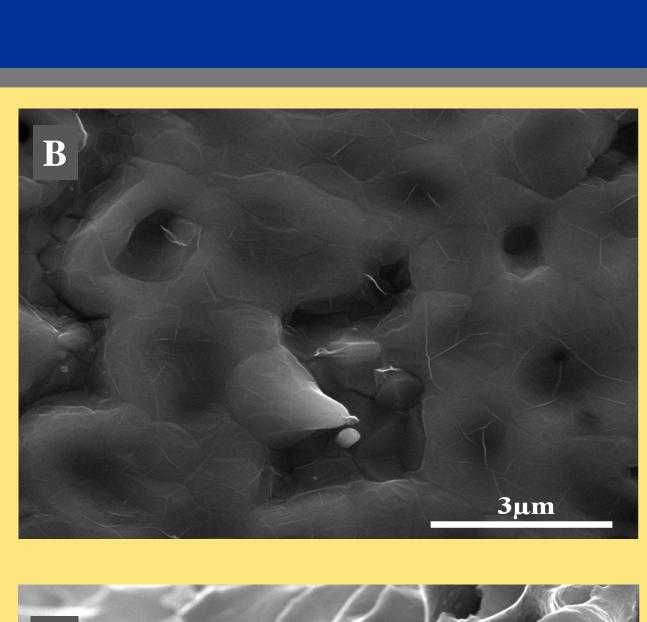
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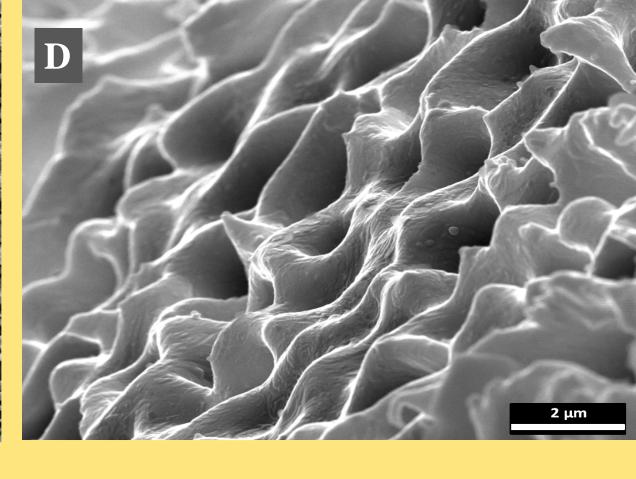
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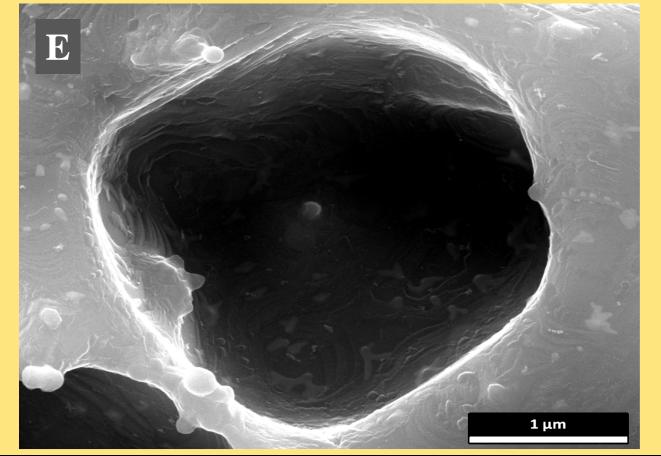


Figure 3: Broad SEM images of SS (A) before CVD growth, (B) after growth with organic vapor, and (C) after growth with fluorinated organic vapor. (D) Image of the surface of fluorinated sample from an angle. (E) View of single pore blanketed in graphene. (F) Inside view of broken substrate to reveal cylindrical structure of pores.

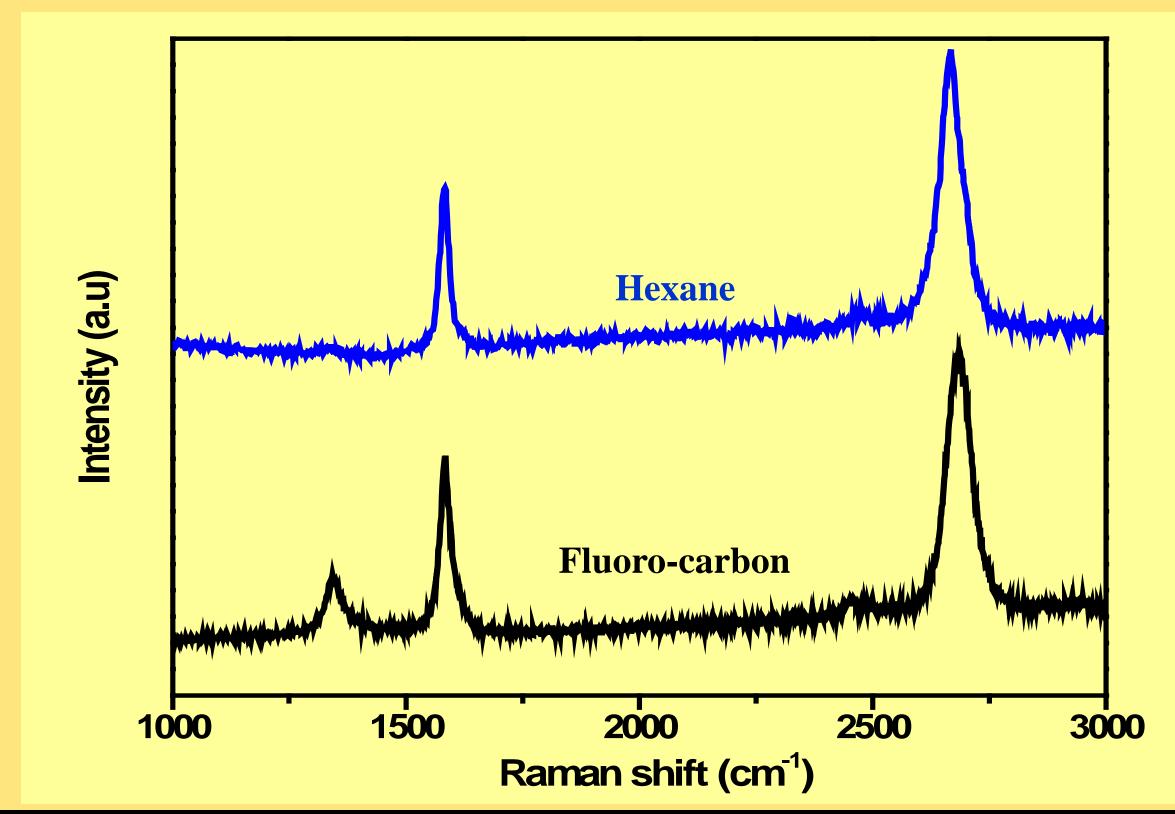
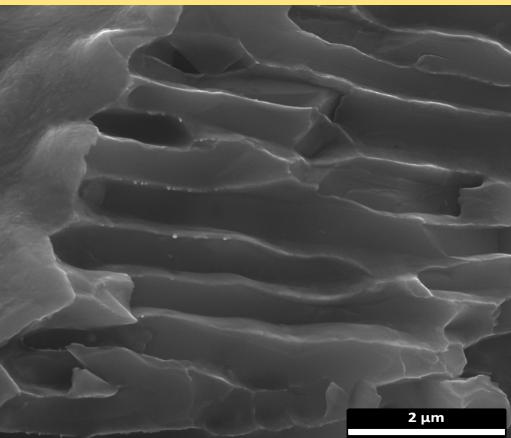
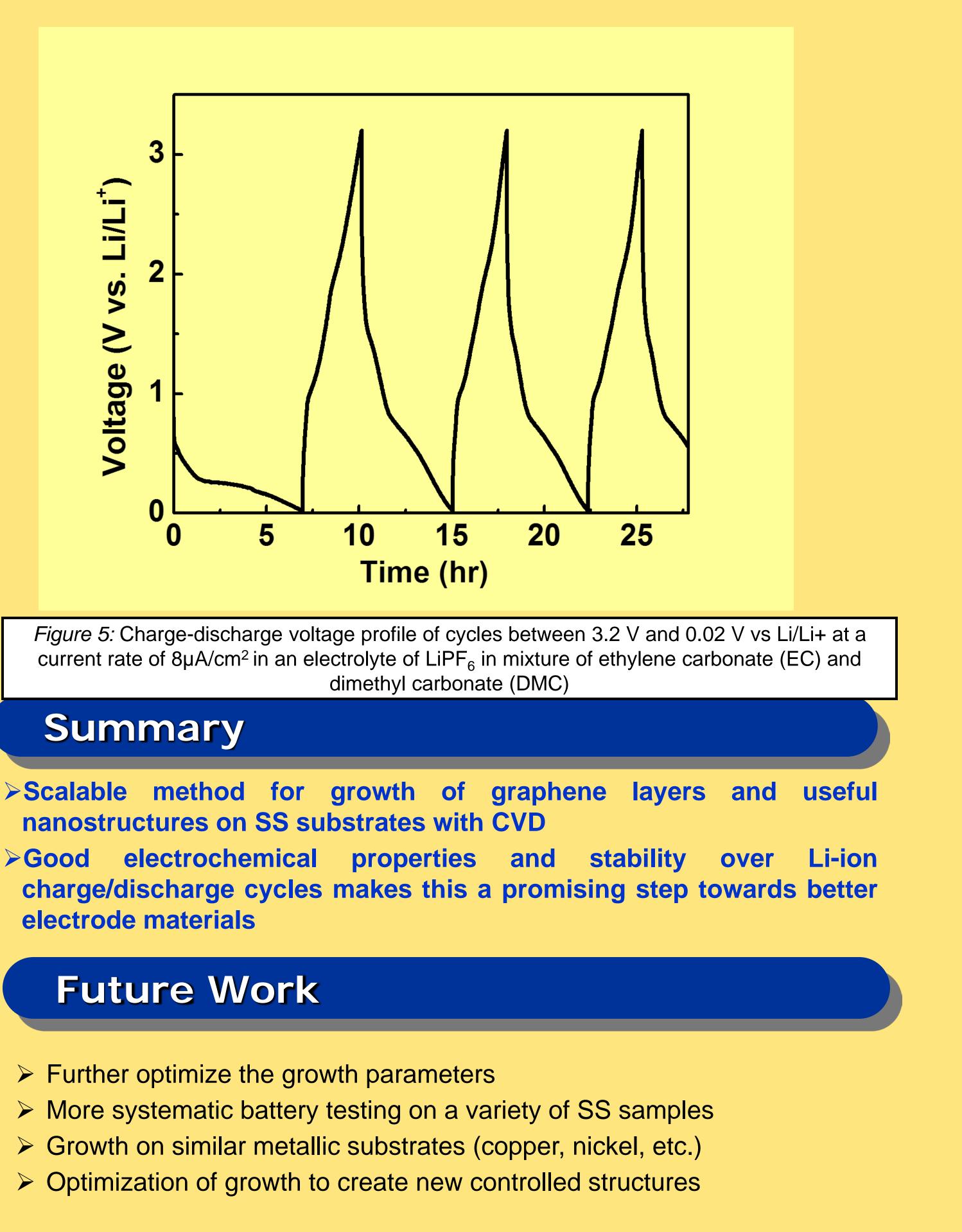


Figure 4: Raman spectra of the graphene grown directly on stainless steel using hexane and a fluorinated organic compound





#### Summary

electrode materials

## **Future Work**

## References

[1] X. Li, et al., Science 2009, 324, 1312; K.S. Kim, et al., Nature 2009, 457, 706. [2] A.C. Ferrari et al., Phys. Rev. Lett. 2006, 97.; D. Wang et al., ACS Nano 2009, 3, 907. [3] H. Gullapalli, et al., Small 2011, 7, No. 12, 1697-1700 [4] A.L.M. Reddy, et al., ACS Nano 2010, 4 (11), 6337–6342



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